

# Whisker Mitigation Strategies for Pb-Free Electronics

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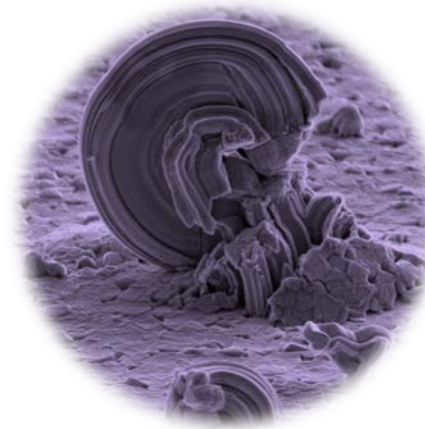
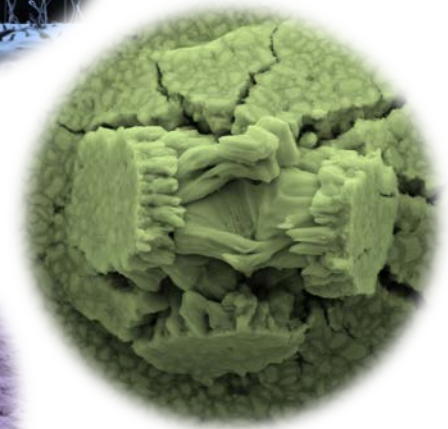
SMART Group

Advances in Electronics Assembly Technology Seminar

16<sup>th</sup> June 2015

# Outline of presentation

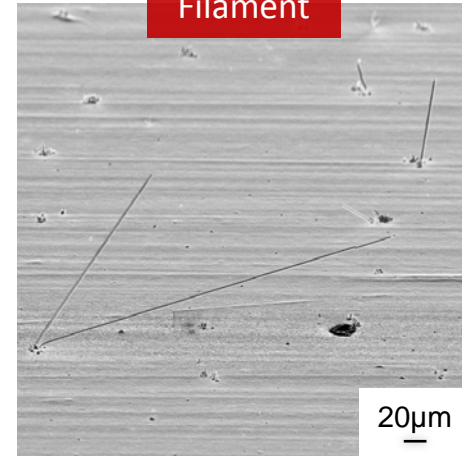
- Background on tin whiskers
- Introduction to WHISKERMIT
- Tin deposits on Cu and brass
- Electrochemical oxidation
- Conformal coatings
- Summary



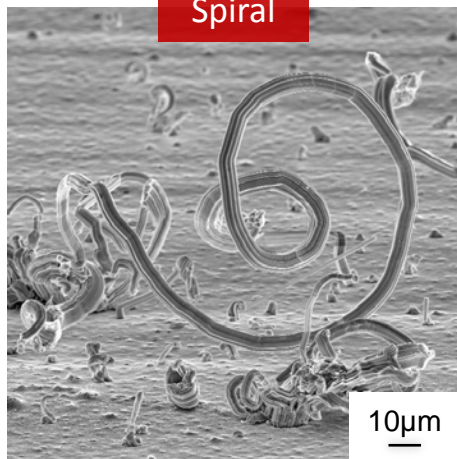
# Background – tin whiskers

- Crystalline growths from a metal surface (e.g. Sn, Zn and Cd)
- Uncertain incubation period before growth
- A few micrometres in diameter and up to several millimetres in length
- Various growth morphologies possible
- Whisker related problems increasing due to environmental legislation, device miniaturisation, lower voltages and harsher environments

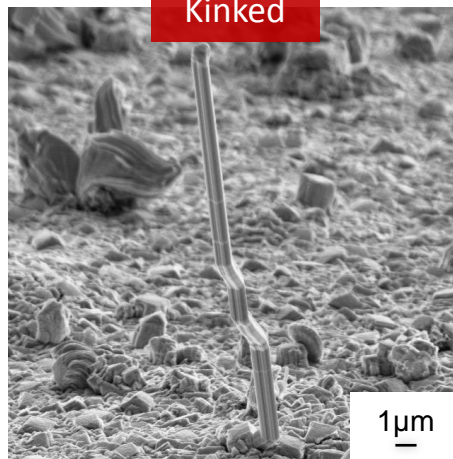
Filament



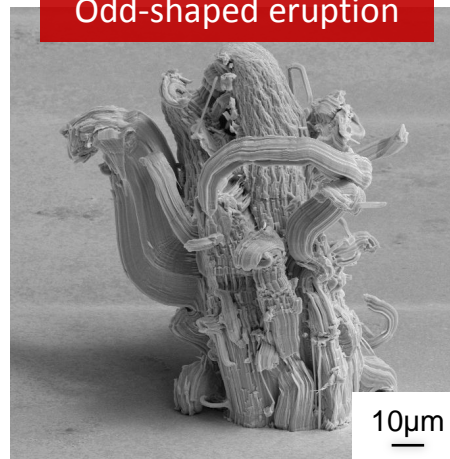
Spiral



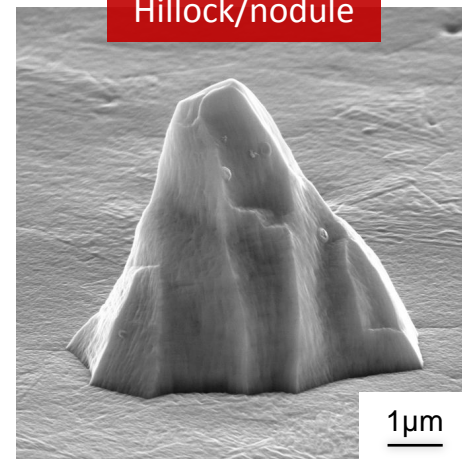
Kinked



Odd-shaped eruption



Hillock/nodule



# Documented electronic failures due to tin whiskers

**NASA: “More than 50  
Electronic Failures due to  
Whisker Growth from  
1946-2006”**

Galaxy satellite

Military failures

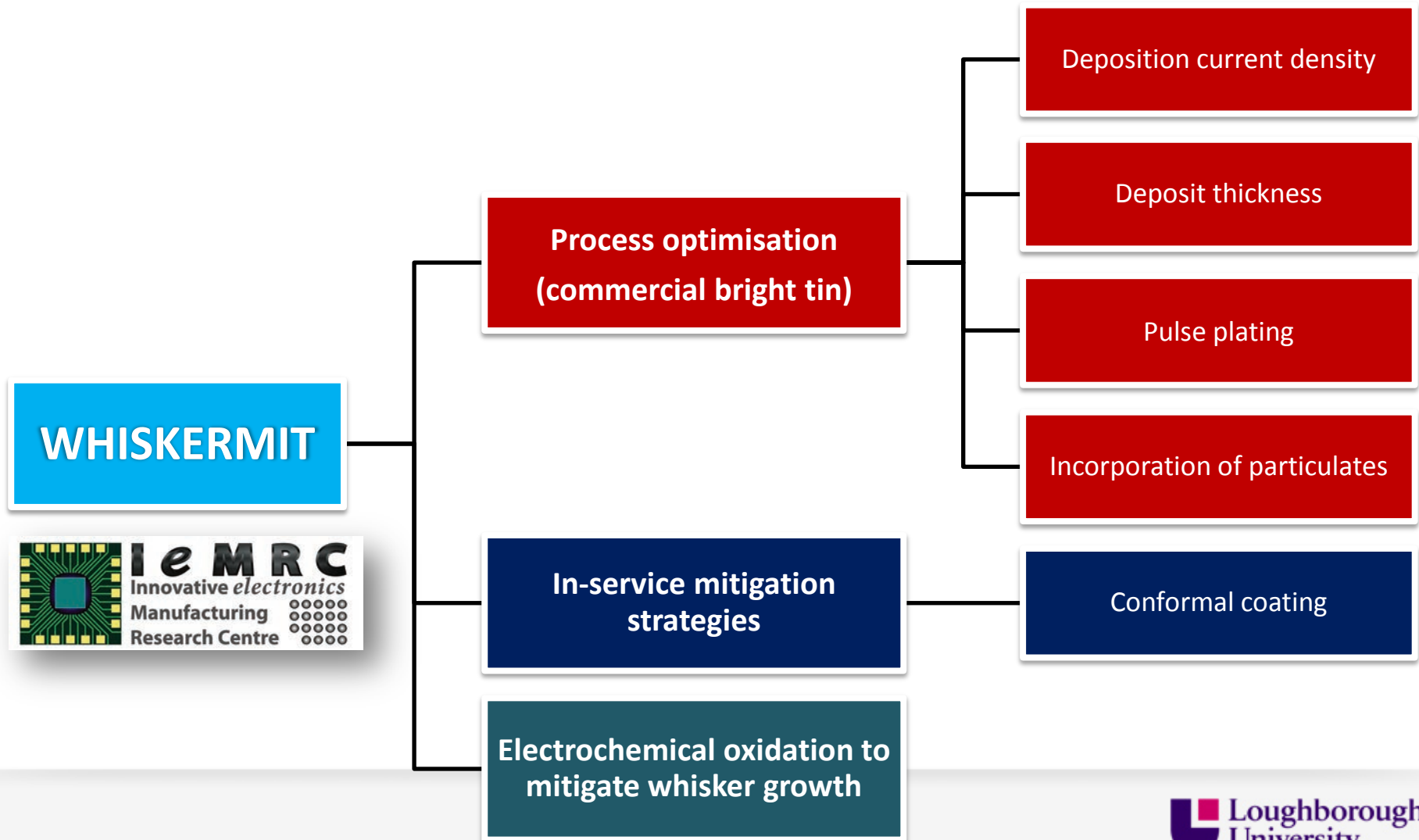
Heart pacemaker recall

Nuclear power plant

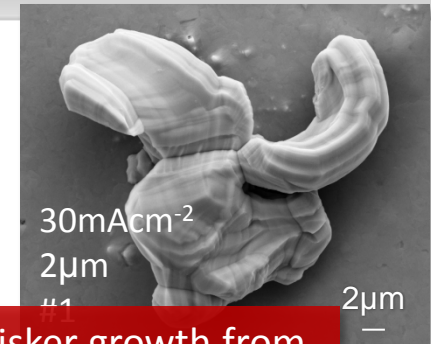
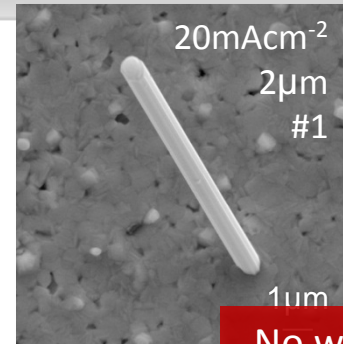
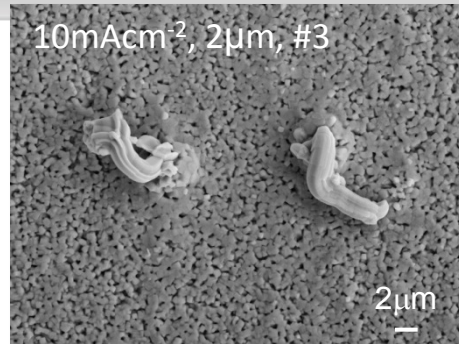
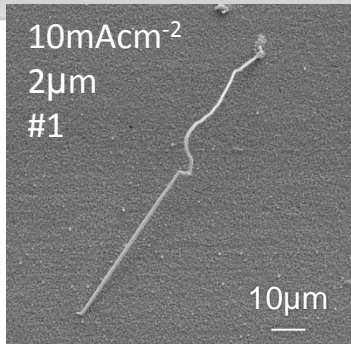
**Documented Incidents:  
Only 10% of Failures  
known to NASA**



# Tin whisker research at Loughborough University



# Effect of process variables: Sn deposits on Cu

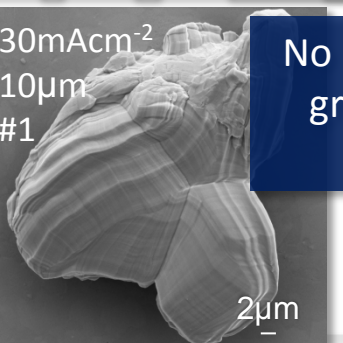
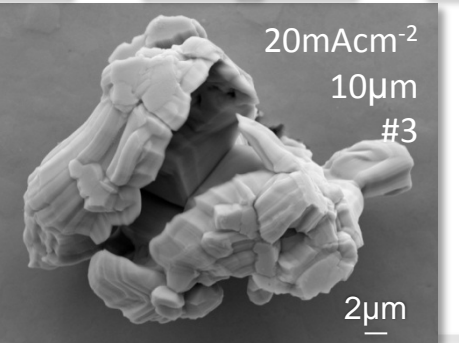
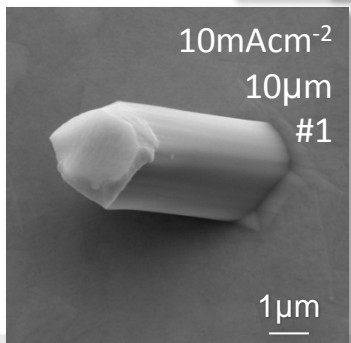


Deposit thickness	10 mA cm <sup>-2</sup>			20 mA cm <sup>-2</sup>			30 mA cm <sup>-2</sup>			40 mA cm <sup>-2</sup>		
	#1	#2	#3 <sup>HT</sup>	#1	#2	#3 <sup>HT</sup>	#1	#2	#3 <sup>HT</sup>	#1	#2	#3 <sup>HT</sup>
2 μm	X		X	X			X					
5 μm			X				X					
10 μm	X					X	X					

No whisker growth from any sample electroplated at 40 mA cm<sup>-2</sup>

No whisker growth observed from 'batch 2' samples

No increase in whisker growth for samples stored in oven

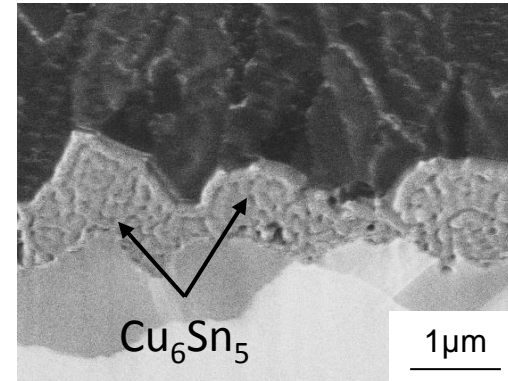
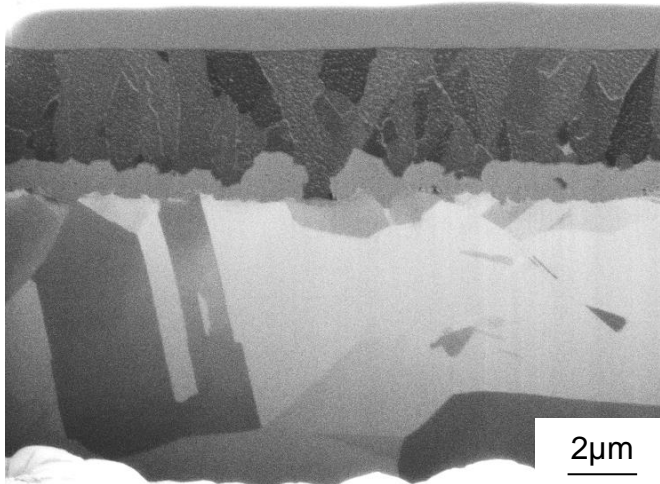


~ 2 years after deposition

# Effect of elevated temperature on intermetallic formation

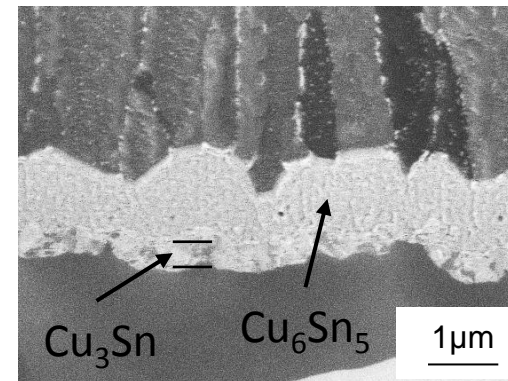
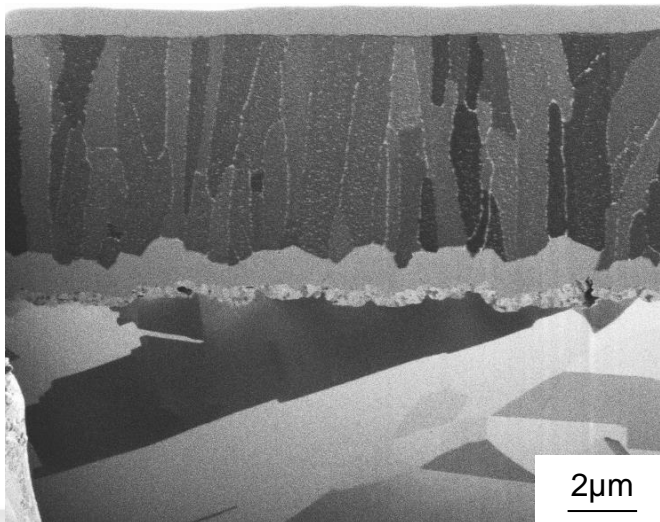
5  $\mu\text{m}$  tin  
20  $\text{mAcm}^{-2}$

**2 years room  
temperature  
storage**



10  $\mu\text{m}$  tin  
20  $\text{mA cm}^{-2}$

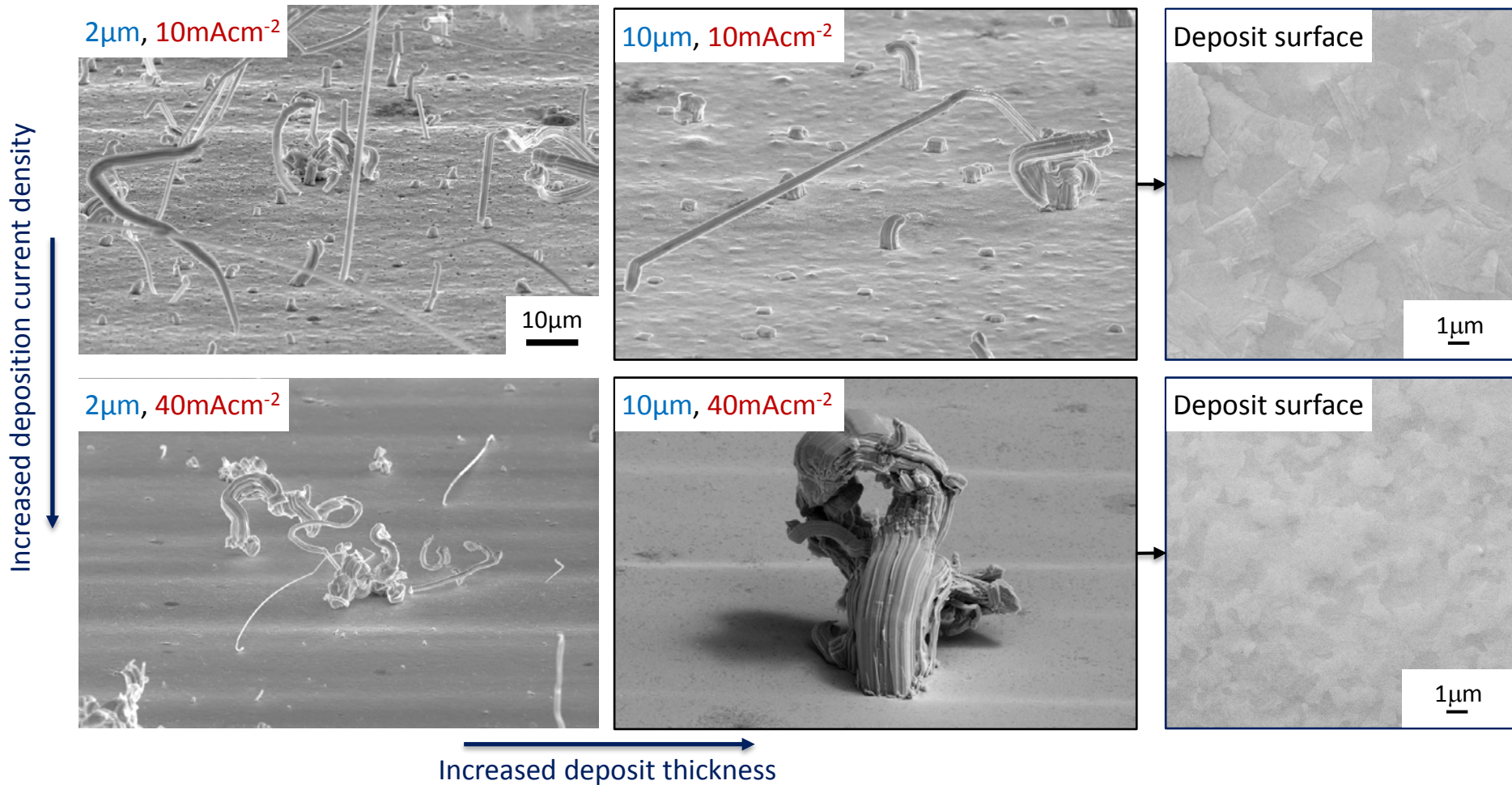
**2 years storage  
includes 5000  
hours at  
55°C/85% RH**



- $\text{Cu}_3\text{Sn}$  layer develops during storage at 55°C
- IMC layer becomes more planar
- No acceleration in whisker growth observed

FIB analysis  $\sim$  2 years after tin deposition

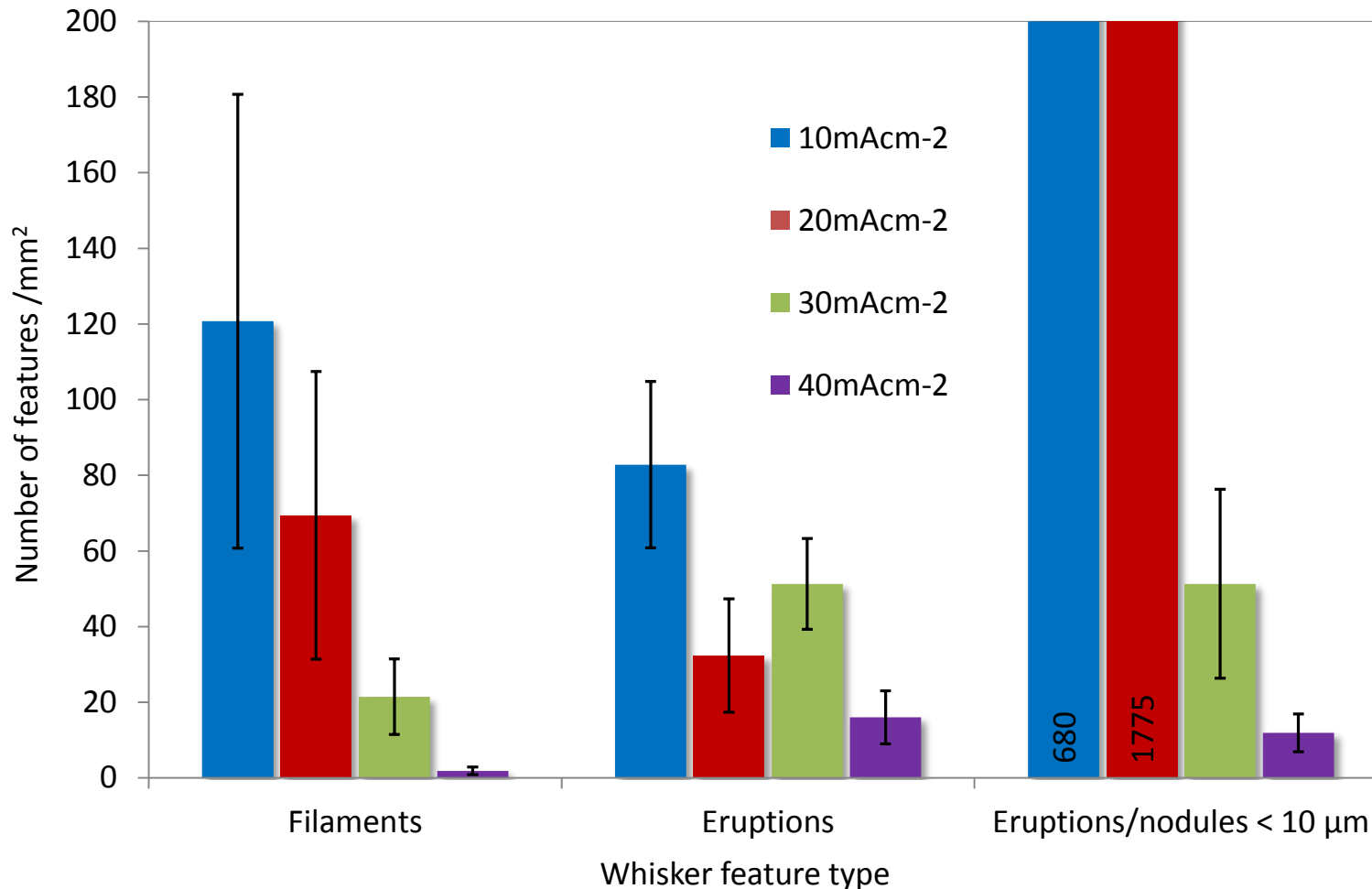
# Effect of process variables: Sn deposits on brass



29 months after deposition

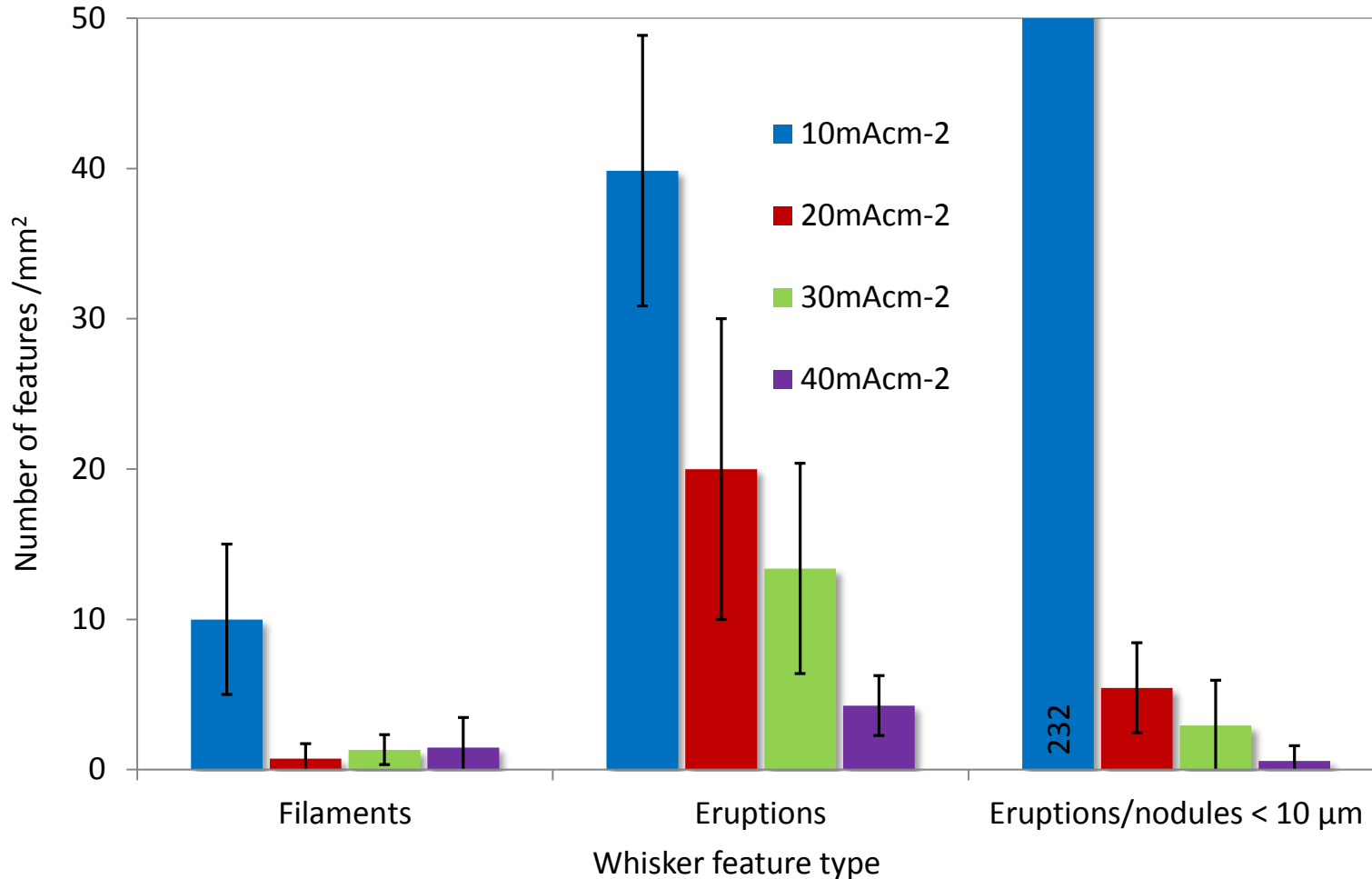


# Effect of deposition current density on whisker growth



Evaluation of whisker density for 2µm tin deposits on brass  
Analysis approx. 33 months after tin deposition  
Storage at room temperature

# Effect of deposition current density on whisker growth

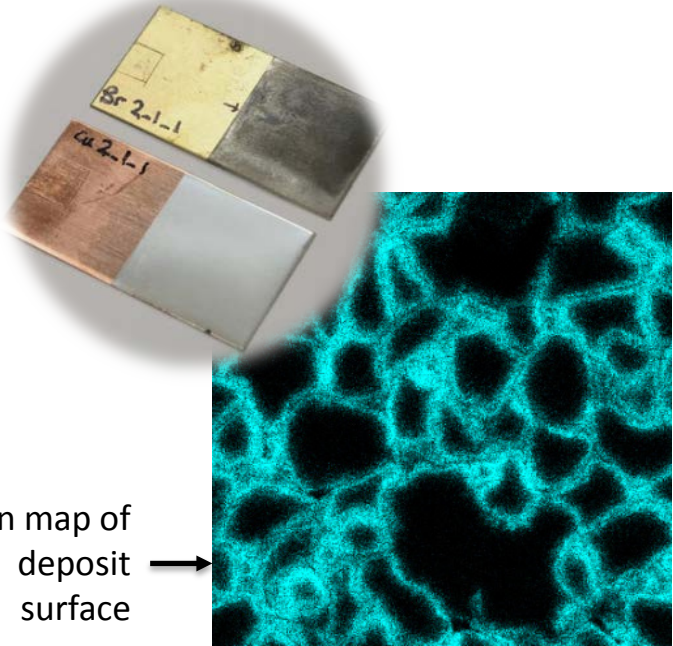


Evaluation of whisker density for **10µm** tin deposits on brass

Analysis approx. 33 months after tin deposition

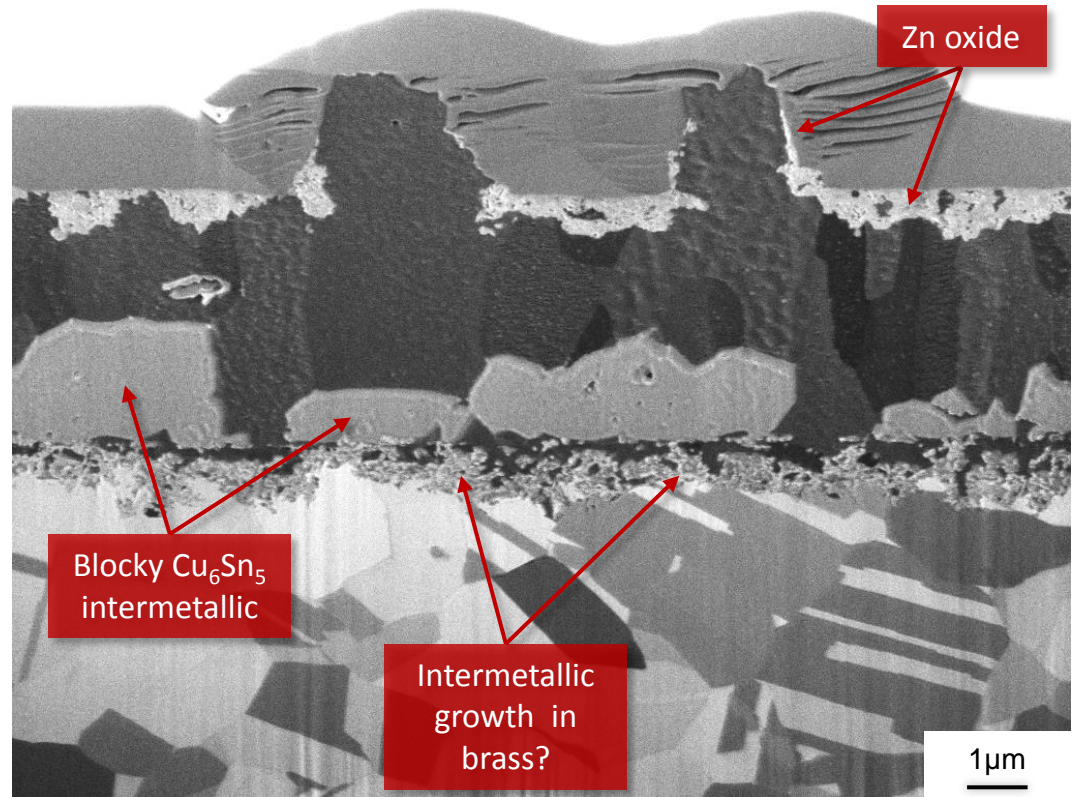
Storage at room temperature

# Sn deposits on brass: whisker mechanism



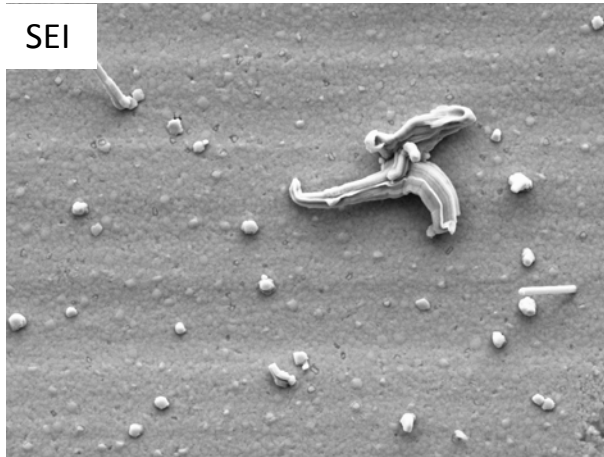
For tin deposits on brass, **whisker growth is primarily driven by zinc oxide formation** at the deposit surface rather than intermetallic growth at the Sn-brass interface

5  $\mu\text{m}$  tin deposit on brass, electroplated at  $10 \text{ mAcm}^{-2}$   
FIB analysis ~29 months after tin deposition

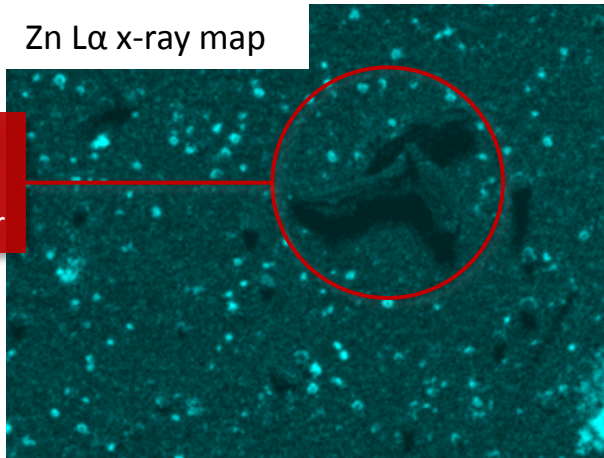


# Tin deposit on brass: Zn present in tin whisker?

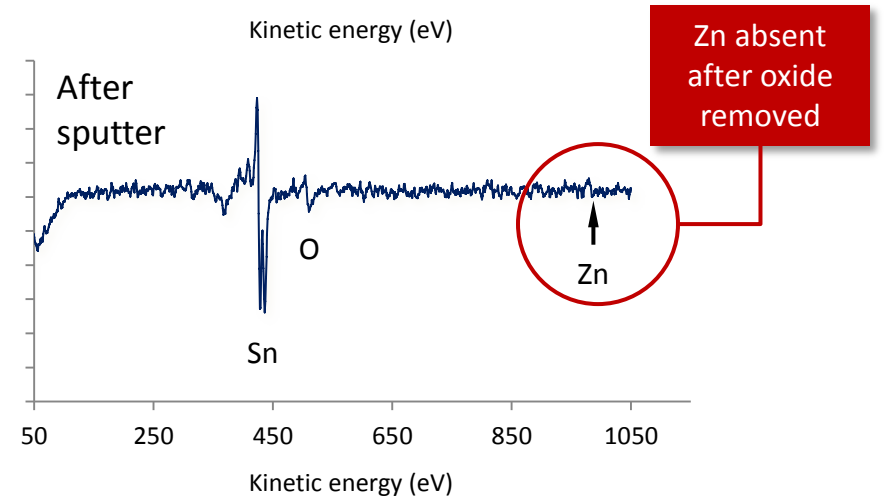
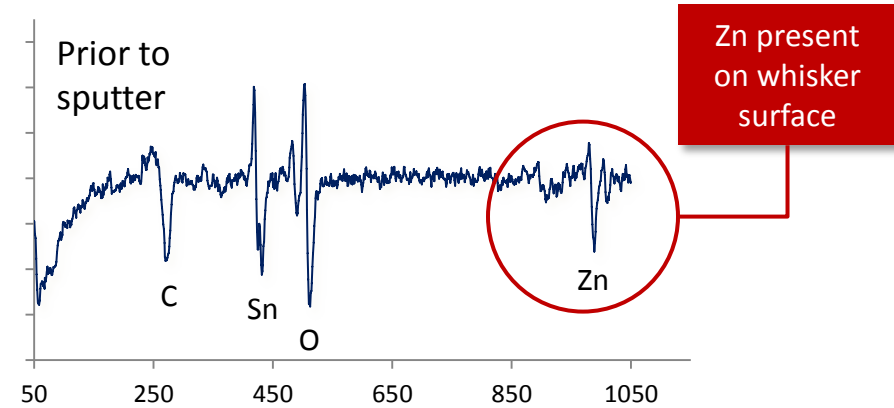
'Bulk' analysis: SEM/EDX mapping



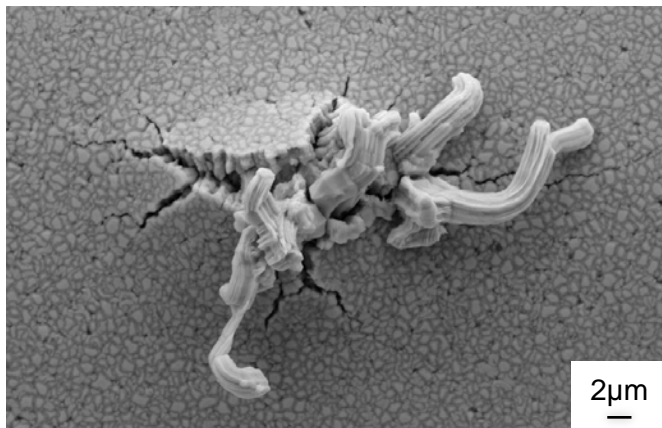
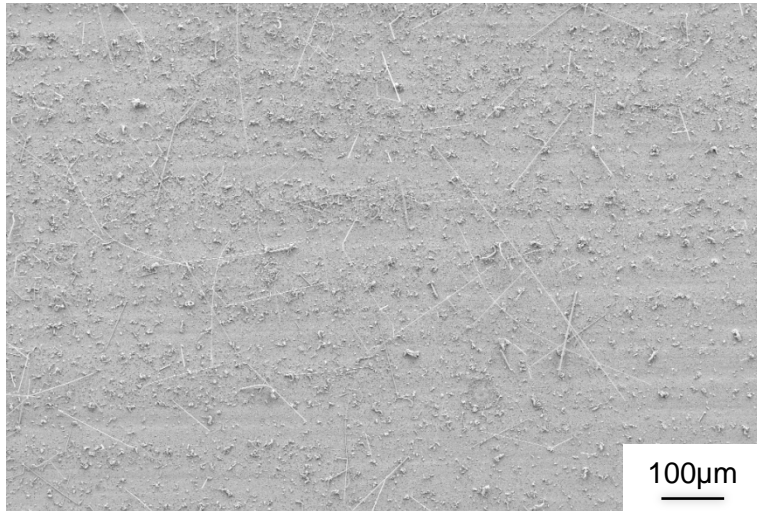
Zn L $\alpha$  x-ray map



Surface analysis: Auger electron spectroscopy

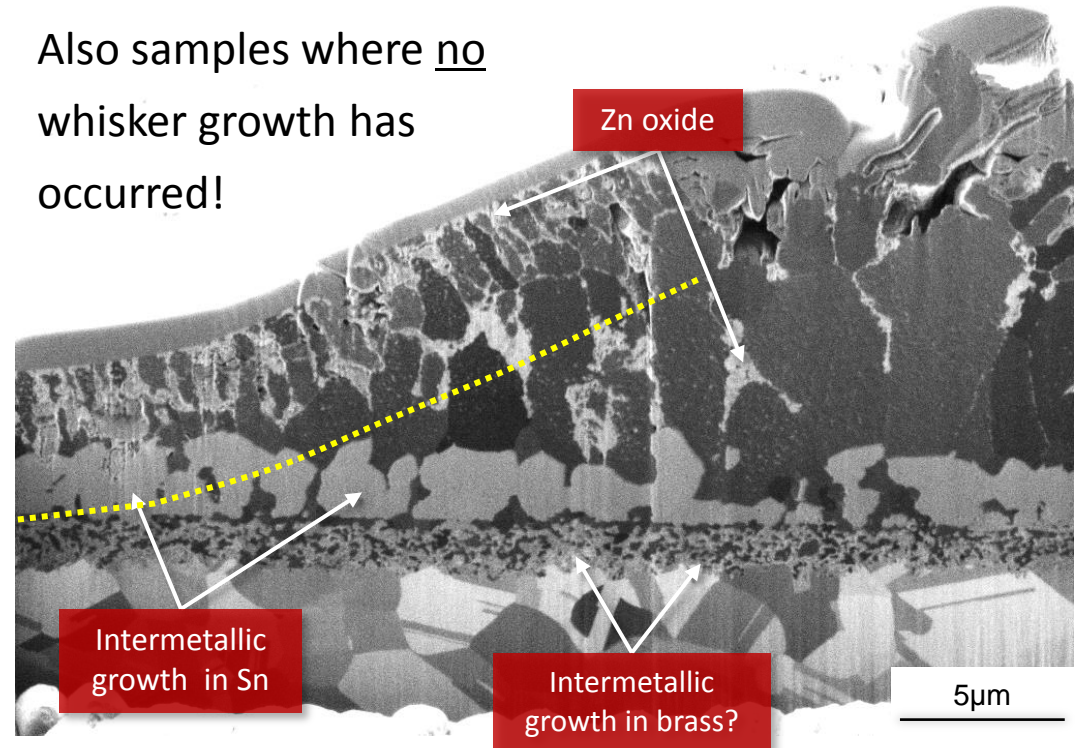


# Sn deposit on brass: effect of elevated temperature



Exposure of Sn deposits on brass generally results in a considerable increase in whisker growth

Also samples where no whisker growth has occurred!

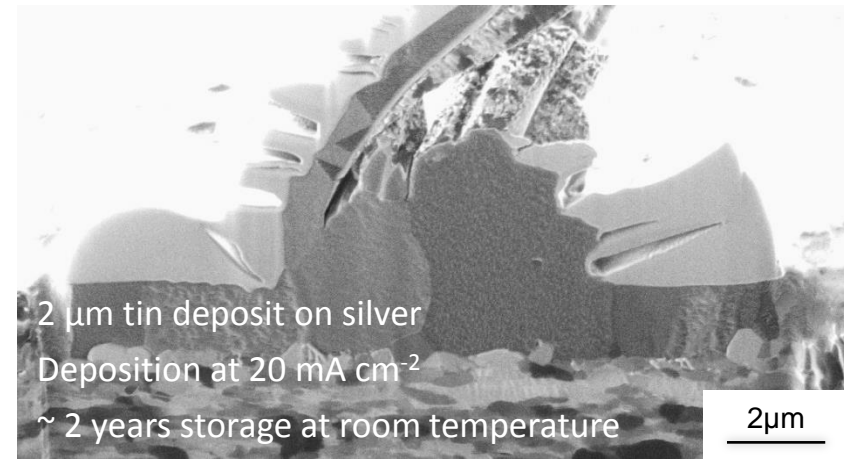
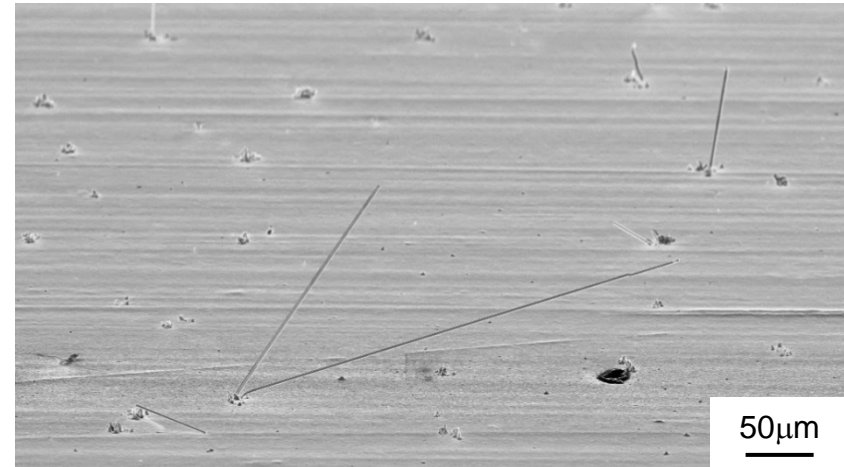


# Effect of electroplating parameters

- For both Sn deposits on Cu and Sn deposits on brass, whisker growth is reduced at higher deposition current densities and increased deposit thicknesses
- Current results only applicable for the specific Sn electroplating bath under investigation
- Significant variation in whisker growth may be observed on nominally identical samples
- Although whisker growth is strongly influenced by electroplating parameters, their control cannot be relied upon to successfully mitigate whisker growth → additional control measures are required

# Whisker growth for tin deposition on silver

- Ag has been considered as a potential underlayer material to mitigate whisker growth for tin deposits on copper
- Sn deposits on silver sheet whisker much more rapidly than equivalent deposits on copper
- Recent results have also demonstrated increased whisker growth for Sn deposits on Cu with an electroplated Ag barrier layer
- According to Crandall <sup>1</sup>: “Sn on Ag is a remarkable whisker producer!” and “holds our internal lab record for prodigious whisker growth”



<sup>1</sup> E. R. Crandall, Factors Governing Tin Whisker Growth, PhD thesis, Auburn University, 2012

# The role of the surface oxide in whisker growth

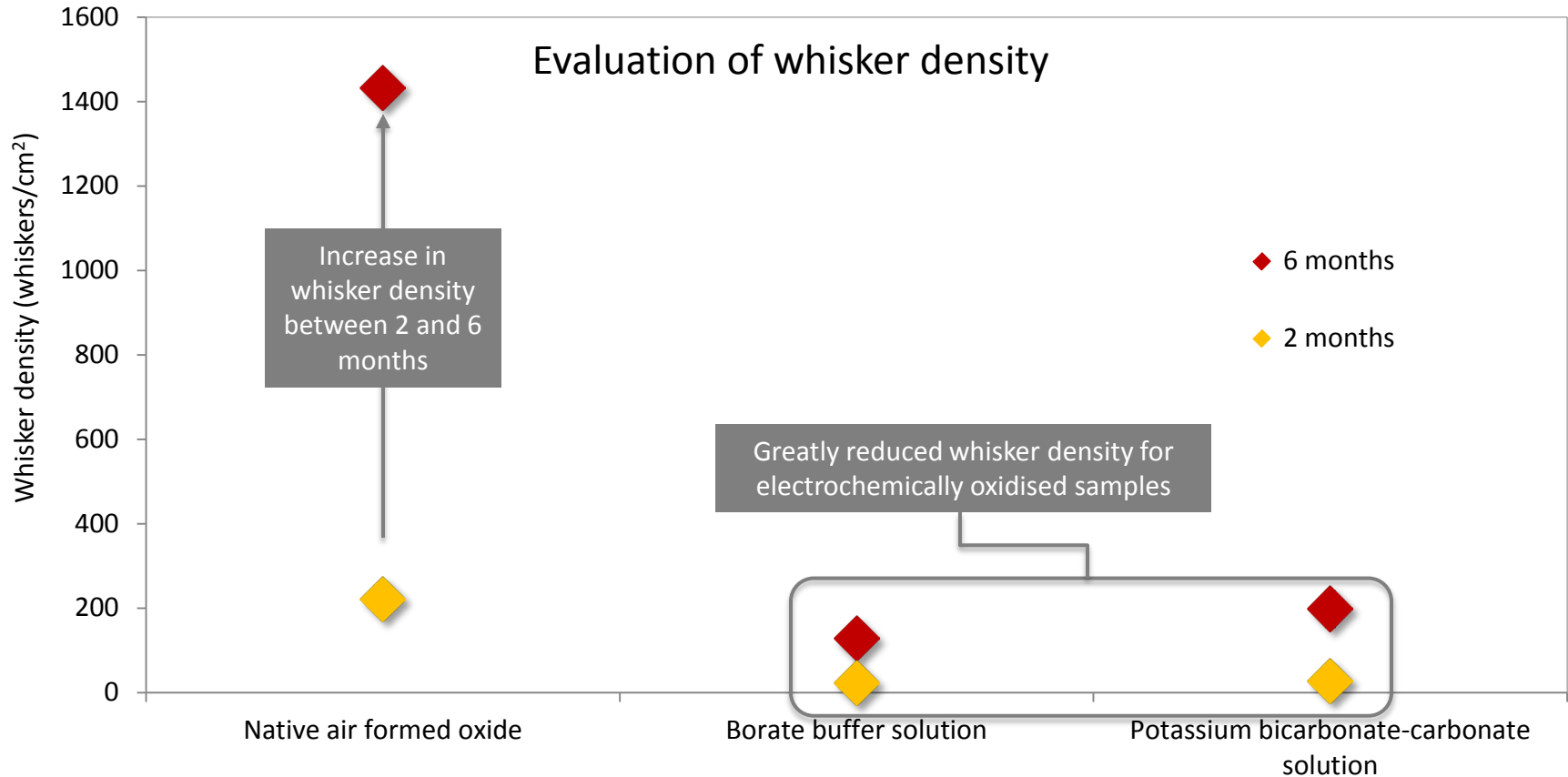
- In 1994, Tu proposed his “**cracked oxide theory**”<sup>1</sup>
  - whisker growth occurs at certain weak spots on the surface where the oxide has been broken
  - In the absence of an oxide no whisker growth would occur
- Later adding<sup>2</sup> ...
  - “if the surface oxide is very thick, it will physically block the growth of any hillocks and whiskers”
- *Can we mitigate whisker growth by increasing the thickness of the surface oxide??*

<sup>1</sup> *Physical Review B* 49, 2030, 1994

<sup>2</sup> *Proceedings of the IEEE Electronic Components and Technology Conference*, 2002 p1194–1200



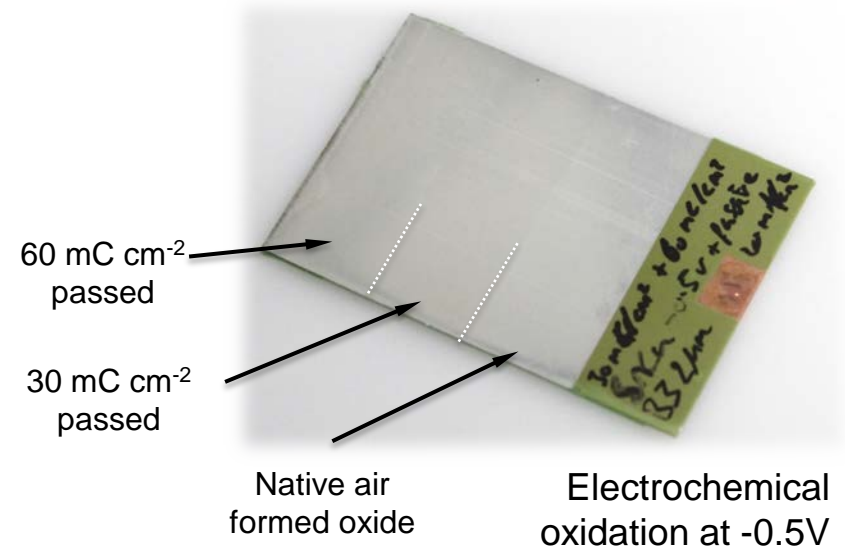
# SnCu deposits on Cu: Electrochemical oxidation at 1.2V



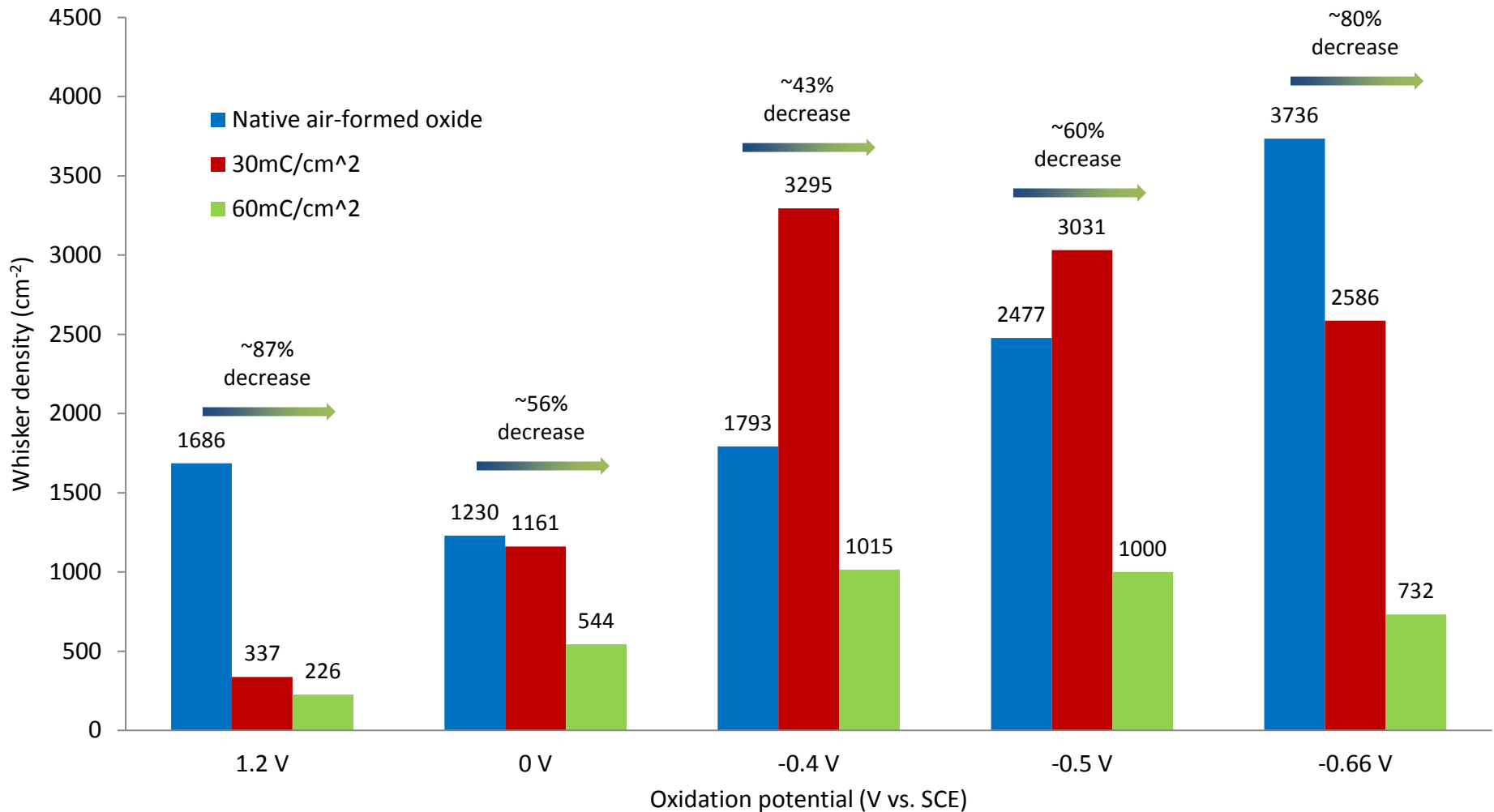
**2  $\mu\text{m}$  Sn-Cu on Cu deposited at  $10 \text{ mAcm}^{-2}$**

# Test coupons to investigate whisker growth

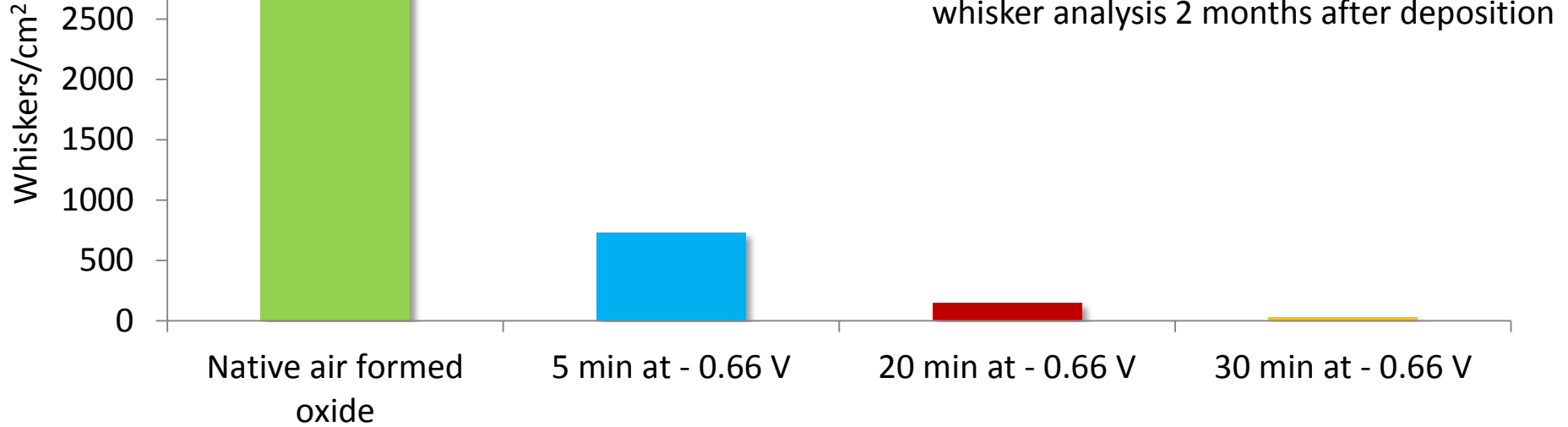
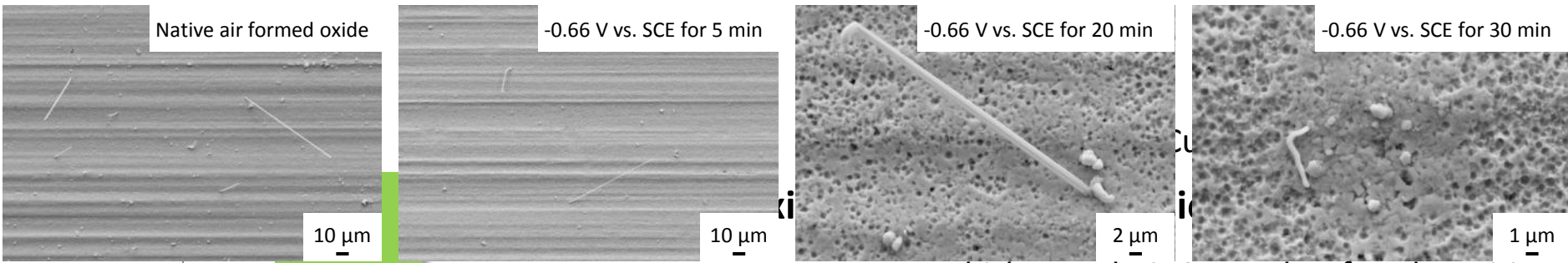
- To more fully investigate the effect of oxidation potential samples have been electrochemically oxidised in a potassium carbonate-bicarbonate bath at **-0.66V**, **-0.5 V**, **-0.4V**, **0 V** and **1.2 V** (all vs. SCE).
- Regions with both 30 and 60 mC cm<sup>-2</sup> charge passed
- Whisker growth evaluated using optical microscopy after ~ 2 months storage at room temperature



# Whisker density after ~ 2 months storage

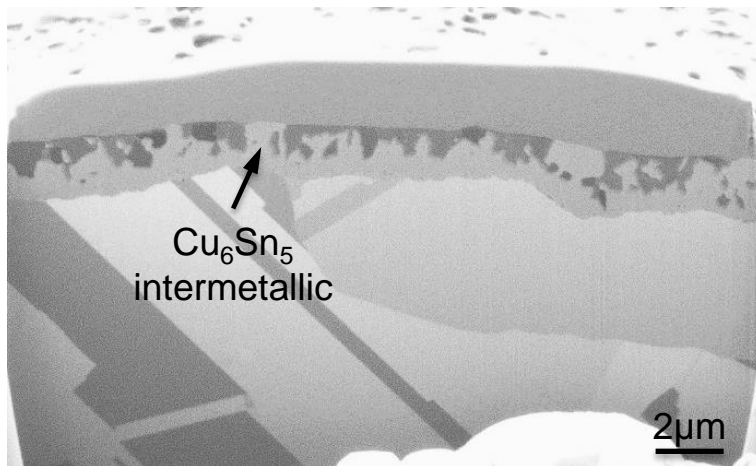


# Effect of oxidation time: whisker growth

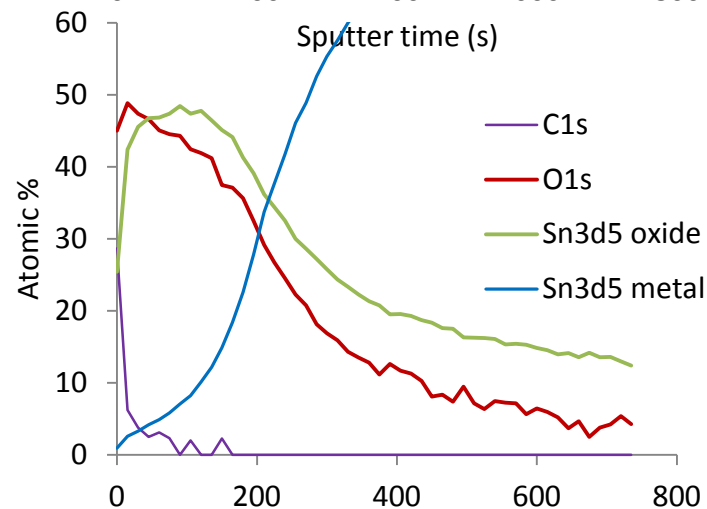
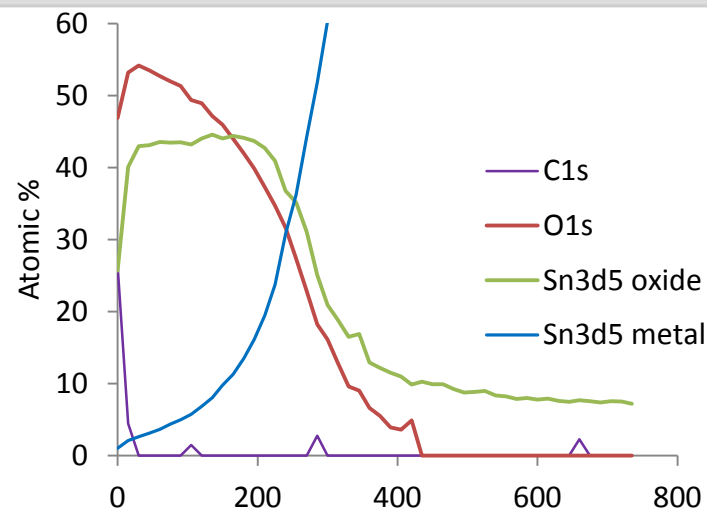
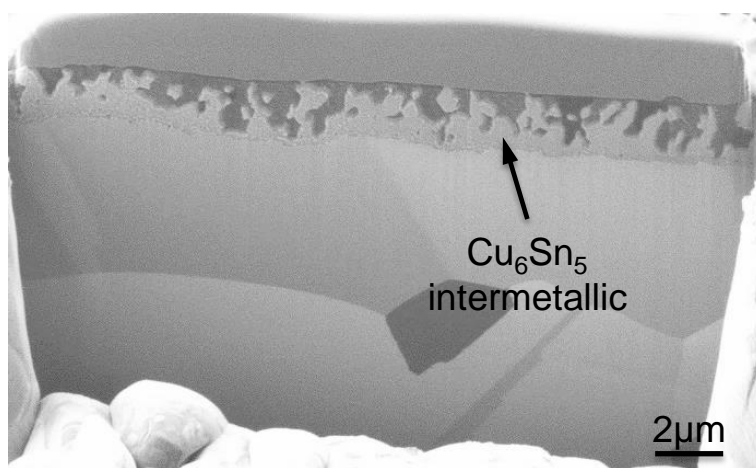


# FIB/XPS analysis of SnCu deposits on Cu: ~2 years storage

SnCu on Cu  
**Electrochemical oxidation**  
at 1.2V  
borate buffer

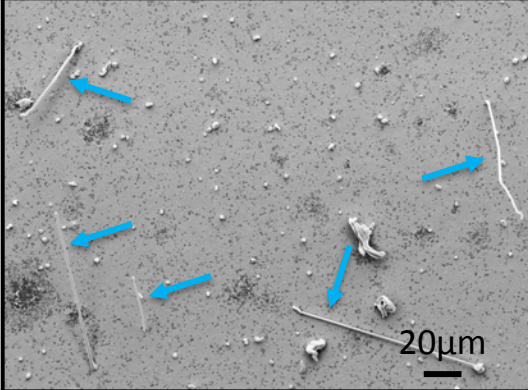
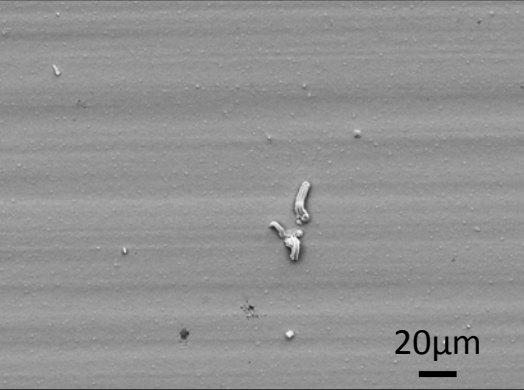
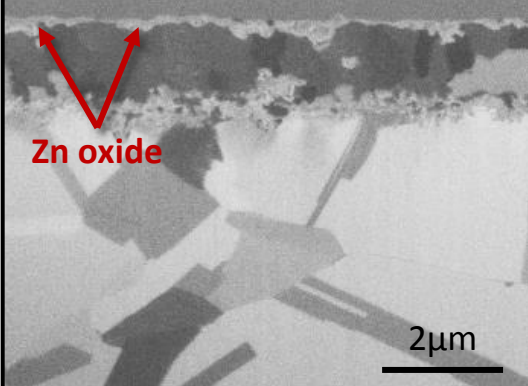
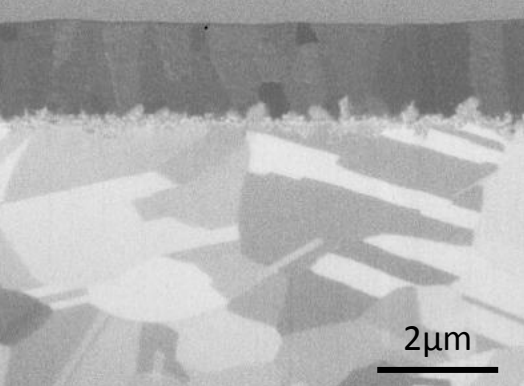


SnCu on Cu  
**Native air formed oxide**



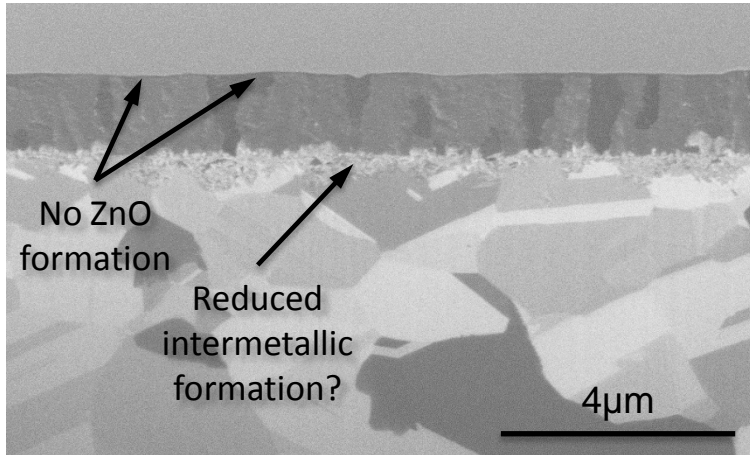
Sputter time (s)

# Sn deposits on brass: whisker growth

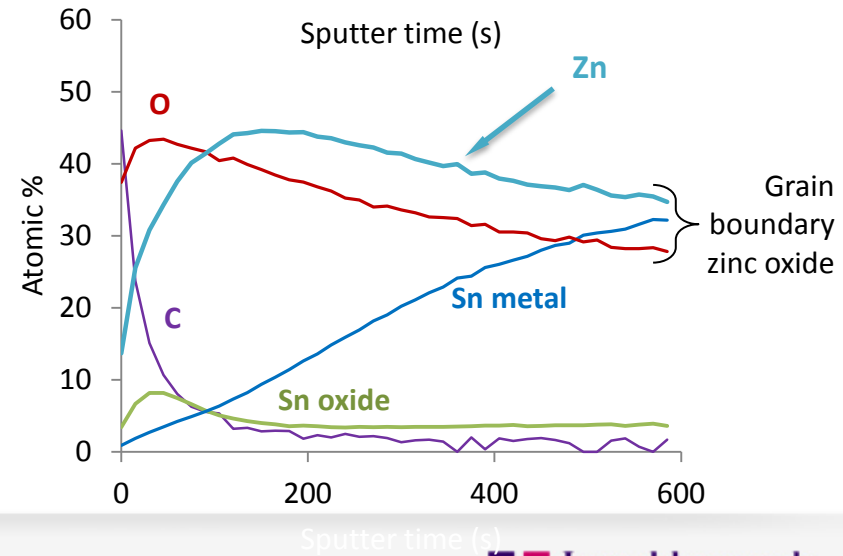
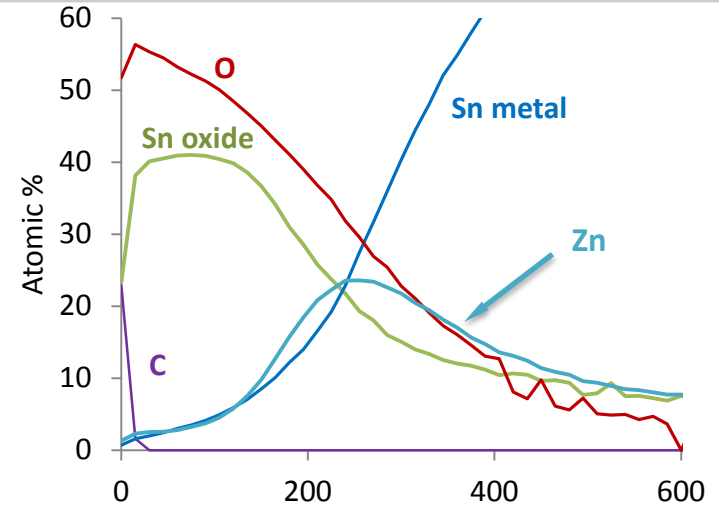
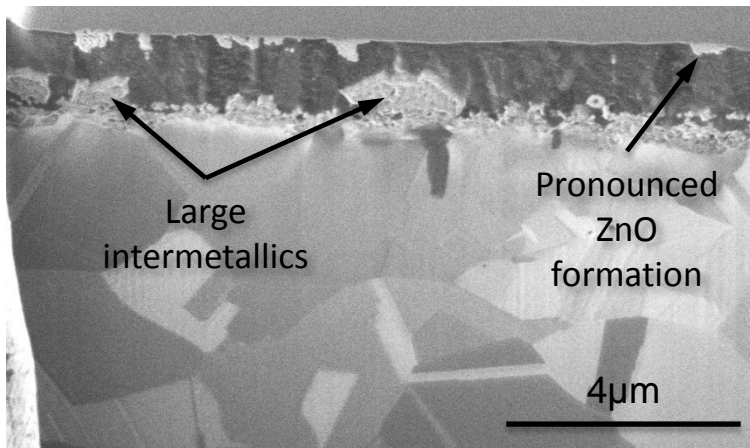
SEM/FIB analysis of 2 $\mu\text{m}$ Sn deposits on brass		Number of whiskers on electrochemically oxidised deposits after 2 years storage (Sample area = $4\text{cm}^2$ )	
Native air formed oxide	Oxidised at 1.2 V vs. SCE	Oxidation potential (V vs SCE)	Average number of whiskers per sample
		1.2 V	$6 \pm 2$
		1.6 V	$2.5 \pm 2$
		2.0 V	$3 \pm 2$

# FIB/XPS analysis of Sn deposits on brass: ~30 months storage

Sn on brass:  
**Electrochemical oxidation**  
 1.2V  
 borate buffer



Sn on brass:  
**Native air formed oxide**



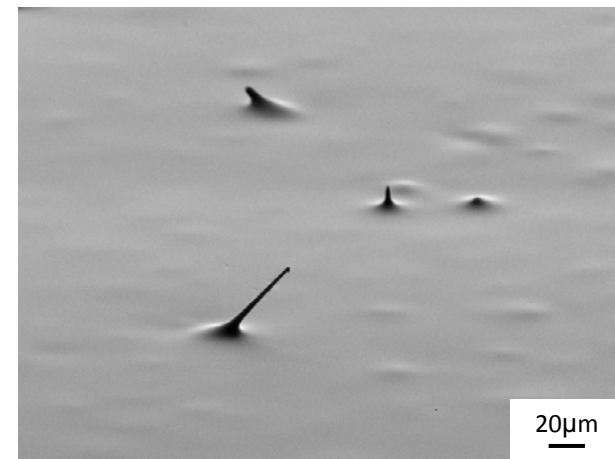
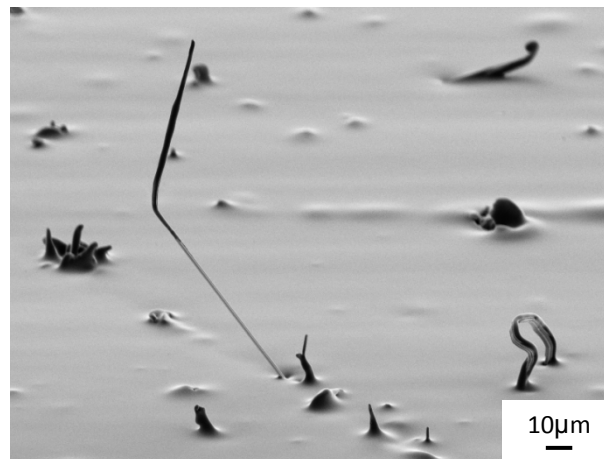
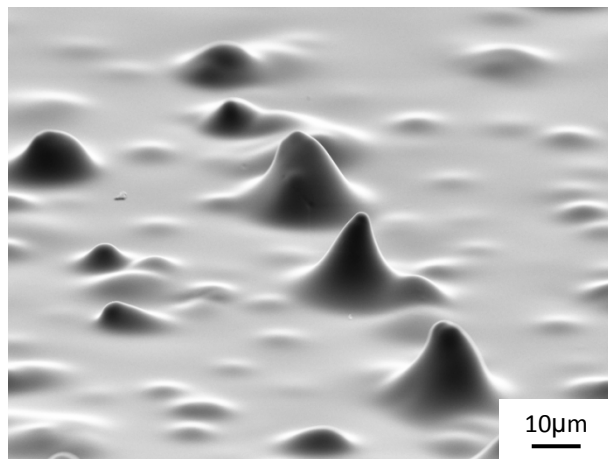
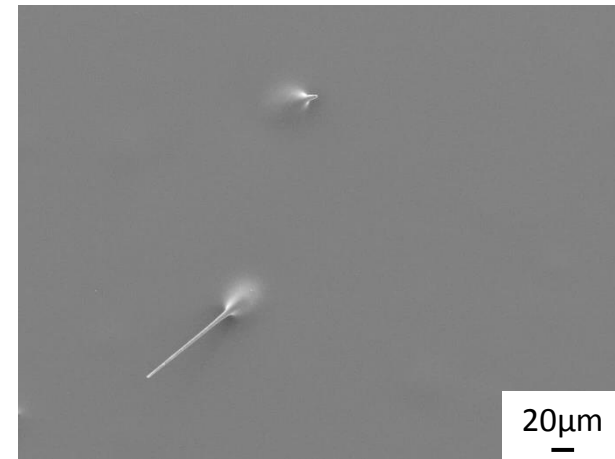
# Whisker mitigation mechanism(s)

- **For Sn(Cu) deposits on Cu**, IMC formation appears unaffected by electrochemical oxidation and therefore whisker mitigation must simply derived from the increased thickness of the oxide layer
- Although whisker density is greatly reduced long filament whiskers are still produced from electrochemically oxidised SnCu deposits
- Electrochemical oxidation does not reduce the driving force for tin whisker growth (*intermetallic formation*)
- **For Sn deposits on brass**, electrochemical oxidation reduces whisker growth by preventing the formation of Zn oxide at the deposit surface
- Reduced IMC formation in electrochemically oxidised samples may also be an influence



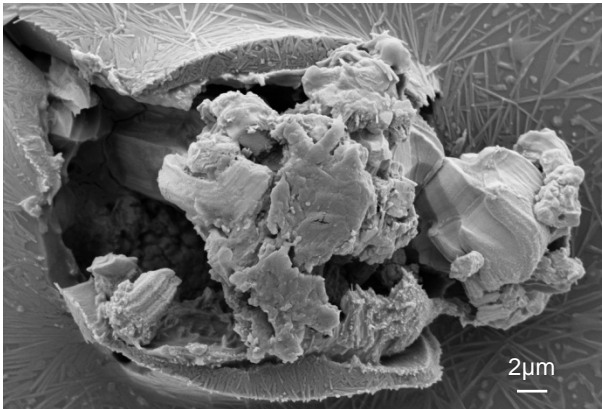
# WHISKERMIT: Conformal coating trials

- Evaluation of commercial urethane, acrylic, silicone and UV cure coatings
- Samples cured both at room temperature and in the oven
- Model coating materials (UV cure) prepared with tailored properties (flexible to rigid)
- Evaluated using tin deposits on brass substrates



# Effect of physical properties on whisker growth

- Original **WHISKERMIT** project demonstrated correlation between coating modulus and whisker growth/penetration
- Develop conformal coatings that are specifically designed to prevent whisker growth

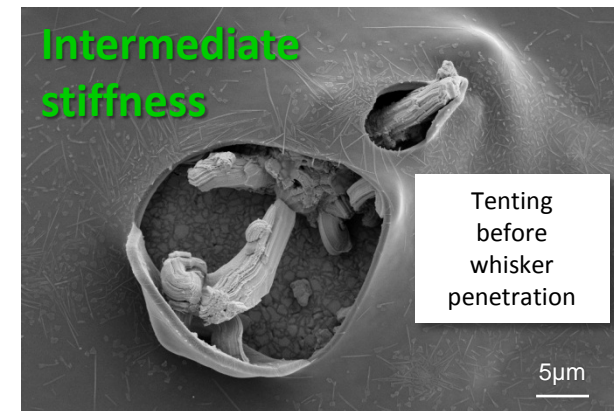


Penetrating whisker  
'flattened' by interaction  
with stiff coating



Low stiffness

No interaction  
between coating and  
penetrating whisker



Intermediate  
stiffness

Tenting  
before  
whisker  
penetration



High stiffness

No tenting or  
whisker  
penetration

**The next step.....**

## **WHISKERMIT 2**

**Improving the whisker mitigation properties of  
polymeric conformal coatings**

# Summary

- Whiskers do not always do what you expect!
- Whisker morphology and density may be modified by control of deposition parameters
- Greatly increased whisker growth for tin deposits on brass
- Silver may not be an ideal barrier layer material
- Electrochemical oxidation has the potential to mitigate whisker growth
- Conformal coatings optimised to mitigate whisker growth are required

Any  
questions?

